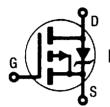
INTERNATIONAL RECTIFIER



REPETITIVE AVALANCHE AND dv/dt RATED

HEXFET® TRANSISTORS IRHM9130



P-CHANNEL

RAD HARD

-100 Volt, 0.30Ω, RAD HARD HEXFET

International Rectifier's P-Channel RAD HARD Technology HEXFETs demonstrate excellent threshold voltage stability and breakdown voltage stability at total radiation doses as high as x105 Rads (Si). Under *identical* pre and post radiation test conditions, International Rectifier's P-Channel RAD HARD HEXFETs retain *identical* electrical specifications up to 1x105 Rads (Si) total dose. No compensation in gate drive circuitry required! In addition, these devices are capable of surviving transient ionization pulses as high as 1x1012 Rads (Si)/Sec, and return to normal operation within a few microseconds. Single Event Effect (SEE) testing of International Rectifier P-Channel RAD HARD HEXFETs has demonstrated virtual immunity to SEE failure. Since the P-Channel RAD HARD process utilizes International Rectifier's patented HEXFET technology, the user can expect the highest quality and reliability in the industry.

P-Channel RAD HARD HEXFET transistors also feature all of the well established advantages of MOSFETs such as voltage control, very fast switching, ease of paralleling, and temperature stability of the electrical parameters.

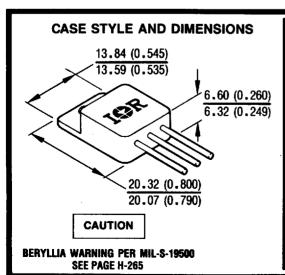
They are well suited for applications such as switching power supplies, motor controls, inverters, choppers, audio amplifiers, and high energy pulse circuits in space and weapons environments.

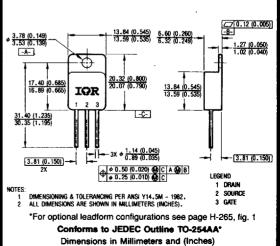
Product Summary

Part Number	BVDSS	R _{DS(on)}	ΙD
IRHM9130	-100V	0.30Ω	-11A

FEATURES:

- Radiation Hardened up to 1x10⁵ Rads (Si)
- Single Event Burnout (SEB) Hardened
- Single Event Gate Rupture (SEGR) Hardened
- Gamma Dot (Flash X-Ray) Hardened
- Neutron Tolerant
- Identical Pre and Post Electrical Test Conditions
- Repetitive Avalanche Rating
- Dynamic dv/dt Rating
- Simple Drive Requirements
- Ease of Paralleling
- Hermetically Sealed
- Electrically Isolated
- Ceramic Eyelets





H-263

Absolute Maximum Ratings

	Parameter	IRHM9130	Units	
ID @ VGS = 12V, TC = 25°C	Continuous Drain Current	-11		
ID @ VGS = 12V, TC = 100°C	Continuous Drain Current	-7.0	_ A	
IDM	Pulsed Drain Current ②	-44	7	
PD @ TC = 25°C	Max. Power Dissipation	75	w	
	Linear Derating Factor	0.6	W/K ®	
V _{GS}	Gate-to-Source Voltage	±20	٧	
EAS	Single Pulse Avalanche Energy ③	500	mJ	
IAR	Avalanche Current ②	-11 (See E _{AR})	A	
EAR	Repetitive Avalanche Energy 2	2.5	mJ	
dv/dt	Peak Diode Recovery dv/dt 4	-5.5	V/ns	
T _J	Operating Junction Storage Temperature Range	−56 to −150	•c	
	Lead Temperature	300 (0.063 in. (1.6mm) from case for 10s)	7 -	
	Weight	9.3 (typical)	9	

Electrical Characteristics @ T_J = 25°C (Unless Otherwise Specified)

	Min.	Тур.	Max.	Units	Test Conditions	
BVDSS	Drain-to-Source Breakdown Voltage	100	_	_	V	VGS = 0V, ID = -1.0 mA
ΔBV _{DSS} /ΔT _J	Temperature Coefficient of Breakdown Voltage	-	-0.087	-	V/°C	Reference to 25°C, I _D = -1.0 mA
R _{DS(on)}	Static Drain-to-Source On-State Resistance		_	0.30	Ω	V _{GS} = -12V, I _D = -7.0A
		_		0.325		V _{GS} = -12V, I _D = -11A
VGS(th)	Gate Threshold Voltage	-2.0	_	~4.0	٧	V _{DS} = V _{GS} , I _D = -1.0 mA
9fs	Forward Transconductance	2.5	-	_	S (U)	V _{DS} ≥ -15V, I _{DS} = -7.0A (5)
loss	Zero Gate Voltage Drain Current	_	_	-25		V _{DS} = 0.8 x Max. Rating, V _{GS} = 0V
		-	_	-250	μА	V _{DS} = 0.8 x Max. Rating V _{GS} = 0V, T _J = 125°C
GSS	Gate-to-Source Leakage Forward		_	-100	nΑ	V _{GS} = -20V
lgss	Gate-to-Source Leakage Reverse		_	100	"	V _{GS} = +20V
Qq	Total Gate Charge	_		34.8		V _{GS} = -12V, I _D = -11A
Q _{g8}	Gate-to-Source Charge	_	_	6.8	nC	V _{DS} = 0.5 x Max. Rating
Q _{gd}	Gate-to-Drain ("Miller") Charge	_		23.1		
^t d(on)	Turn-On Delay Time	_	_	30		V _{DD} = -50V, I _D = -11A, R _G = 7.5Ω
t _r	Rise Time	-	-	70	ns	
^t d(off)	Turn-Off Delay Time		-	70	113	
ty	Fall Time	_		70		
LD	Internal Drain Inductance	-	8.7	-	nH	Measured from the drain lead, 6mm (0.25 in.) from package to center of die. Modified MOSFET symbol showing the internal inductances.
L _S	Internal Source Inductance	_	8.7	_		Measured from the source lead, 6mm (0.25 in.) from package to source bonding pad.
C _{iss}	Input Capacitance	_	1100	_		V _{GS} = 0V, V _{DS} = -25V
C ₀₈₈	Output Capacitance	_	310	_	ρF	f = 1.0 MHz
C _{rss}	Reverse Transfer Capacitance		55	_		

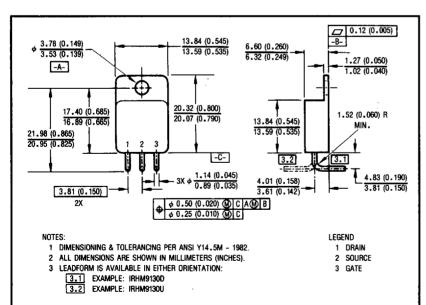
Source-Drain Diode Ratings and Characteristics

Parameter		Min.	Тур.	Max.	Units	Test Conditions		
ls	S Continuous Source Current (Body Diode)		-	-11		Modified MOSFET symbol showing the integral Reverse p-n junction rectifier.		
^I SM	Pulse Source Current (Body Diode) ②	_	-	-44	,			
V _{SD}	Diode Forward Voltage	_	-	-3.0	V	T _J = 25°C, I _S = -11A, V _{GS} = 0V (§)		
t _{rr}	Reverse Recovery Time	T -	_	250	ns	$T_J = 25^{\circ}C$, $ F = -11A$, $di/dt \le -100 A/\mu s$ \$		
Q _{RR}	Reverse Recovery Charge	_	_	2.6	μC	V _{DD} ≤ -50V		
ton	Forward Turn-On Time	Int	rinsic turn-	on time is	negligible.	. Turn-on speed is substantially controlled by L _S + L _D .		

Thermal Resistance

RthJC	Junction-to-Case	_		1.67		
RthJA	Junction-to-Ambient	_	_	30	K/W (6)	
RthCS	Case-to-Sink		0.21			Typical socket mount

- ② Repetitive Rating; Pulse width limited by maximum junction temperature. Refer to Current HEXFET reliability report
- ③ @ V_{DD} = -25V, Starting T_J = 25°C, L ≥ 6.2 mH, R_G = 25Ω, Peak I_L = -11A
- **④** I_{SD} ≤ −11A, di/dt ≤ −140 A/ μ s, V_{DD} ≤ BV_{DSS}, T_J ≤ 150°C Suggested R_G = 7.5Ω
- ⑤ Pulse width ≤ 300 μs; Duty Cycle ≤ 2%
- ⑥ K/W = °C/W W/K = W/°C
- Total Dose Irradiation with V_{GS} Bias.
 -12 volt V_{GS} applied and V_{DS} = 0 during irradiation per MiL-STD-750, method 1019.
- Total Dose Irradiation with V_{DS} Bias. V_{DS} = 0.8 rated BV_{DS} (pre-radiation) applied and V_{GS} = 0 during irradiation per MIL-STD-750, method 1019.
- This test is performed using a flash x-ray source operated in the e-beam mode (energy ~ 2.5 Mev), 30 nsec pulse.
- Study sponsored by NASA. Evaluation performed at Brookhaven National Labs.
- (1) All Pre-Radiation and Post-Radiation test conditions are identical to facilitate direct comparison for circuit applications.



Packages containing beryilla shall not be ground, sandblassed, machined, or have other operations performed on them which will produce beryilla or beryillum dust. Furthermore, beryillum oxide packages shall not be piaced in acids that will produce furms containing beryillum.

BERYLLIA WARNING PER MIL-S-19500

Fig. 1 - Optional Leadforms for Outline TO-254AA

Radiation Performance of P-Channel Rad Hard HEXFET's

International Rectifier Radiation Hardened HEXFETs are tested to verify their hardness capability. The hardness assurance program at International Rectifier uses two radiation environments.

Every manufacturing lot is tested in a low dose rate (total dose) environment per MIL-STD-750, test method 1019. International Rectifier has imposed a standard gate voltage of -12 volts per note 7 and a VDSS bias condition equal to 80% of the device rated voltage per note 8. Pre and Post radiation limits of the devices irradiated to 1x10⁵ Rads (Si) are identical and are presented in table 1. The values in Table 1 will be met for either of the two low dose rate test circuits that are used.

Both pre and post radiation performance are tested and specified using the same drive circuitry and test conditions in order to provide a direct comparison. It should be noted that at a radiation level of 1x10⁵ Rads (Si) no change in limits are specified in DC parameters.

High dose rate testing may be done on a special request basis, using a dose rate up to 1x1012 Rads (Si)/Sec.

International Rectifier radiation hardened P-Channel HEXFETs are considered to be Neutron tolerant as stated in MIL-S-19500 Group D. International Rectifier P-Channel radiation hardened HEXFETs have been characterized in a heavy ion Single Event Effects environment and the results are shown in Table 3.

Table 1. Low Dose Rate 7 8

		IRHA	19130	1	
	Parameter		ads (Si)	Units	Test Conditions ①
		min.	max.	1	
BVDSS	Drain-to-Source Breakdown Voltage	-100	_	v	V _{GS} = 0V, I _D = -1.0 mA
VGS(th)	Gate Threshold Voltage (5)	-2.0	-4.0	1	VGS = VDS, ID = -1.0 mA
^I GSS	Gate-to-source Leakage Forward	_	-100	nA	V _{GS} = -20V
IGSS	Gate-to-Source Leakage Reverse	_	+100]	V _{GS} = +20V
loss	Zero Gate Voltage Drain Current	-	-25	μΑ	VDS = 0.8 x Max Rating, VGS = 0V
R _{DS(on)1}	Static Drain-to-Source ⑤ On-State Resistance One		0.30	Ω	V _{GS} = -12V, I _D = -7.0A
V _{SD}	Diode Forward Voltage ⑤	_	-3.0	V	T _C = 25°C, I _S = -11A, V _{GS} = 0V

Table 2. High Dose Rate 9

	1011	Rads (S	i)/sec	c 10 ¹² Rads (Si)/sec				
Parameter	Min.	Тур.	Мах.	Min.	Тур.	Max.	Units	Test Conditions
VDSS Drain-to-Source Voltage	-	_	-80	_	_	-80	٧	Applied drain-to-source voltage during gamma-dot
lpp	T -	-60	—	_	-60		Α	Peak radiation induced photo-current
di/dt		<u> </u>	-800	_		-160	A/µsec	Rate of rise of photo-current
L ₁	0.1	_	l –	0.5	_		μН	Circuit inductance required to limit di/dt

Table 3. Single Event Effects

Parameter	Тур	Units	lon	LET (Si) (MeV/mg/cm ²)	Range (μm)	V _{DS} Bias (V)	V _{GS} Bias (V)
V _{DS} 00	-100	v	Ni	28	~41	-100	+5

- Repetitive Rating; Pulse width Ilmited by maximum junction temperature.
 Refer to Current HEXFET reliability report
- ③ @ V_{DD} = -25V, Starting T_J = 25°C, L ≥ 6.2 mH, R_G = 25Ω, Peak I_I = -11A
- ¶ I_{SD} ≤ −11A, di/dt ≤ −140 A/µs, V_{DD} ≤ BV_{DSS}, T_J ≤ 150°C Suggested R_G = 7.5Ω
- ⑤ Pulse width ≤ 300 μs; Duty Cycle ≤ 2%
- 6 K/W = °C/W W/K = W/°C
- Total Dose Irradiation with V_{GS} Bias. -12 voit V_{GS} applied and V_{DS} = 0 during irradiation per MiL-STD-750, method 1019.
- Total Dose Irradiation with V_{DS} Blas. V_{DS} = 0.8 rated BV_{DS} (pre-radiation) applied and V_{GS} = 0 during irradiation per MIL-STD-750, method 1019.
- This test is performed using a flash x-ray source operated in the e-beam mode (energy ~2.5 MeV), 30 nsec pulse
- Study sponsored by NASA. Evaluation performed at Brookhaven National Labs.
- All Pre-Radiation and Post-Radiation test conditions are identical to facilitate direct comparison for circuit applications.